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## AUG 2 4 2005

67,124-014; R-05323

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:

Halwan

**SERIAL NO.:** 

10/736,260

FILED:

12/15/2003

GROUP ART:

3744

**EXAMINER:** 

Jiang, Chen Wen

FOR:

Control Logic for Maintaining Proper Solution Concentration in an

Absorption Chiller in co-Generation Applications

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

## **AMENDMENT**

Dear Sir:

In response to the office action of 24 March, 2005, please amend the above-identified application as follows: